

Image Rce

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **WATANABE, Kenichi**

Group Art Unit: **2815**

Serial No.: **09/987,012**

Examiner: **Chris C. Chu**

Filed: **November 13, 2001**

P.T.O. Confirmation No.: 6363

For. **SEMICONDUCTOR WAFER DEVICE HAVING SEPARATED CONDUCTIVE PATTERNS IN PERIPHERAL AREA AND ITS MANUFACTURING METHOD**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: December 17, 2003

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated August 1, 2003 for a second month from December 1, 2003 to January 1, 2004. A previously submitted Request for Extension of Time has extended the period for response from November 1, 2003 to December 1, 2003.

Attached please find a check in the amount of \$1080.00 to cover the cost of the extension (\$310.00) and to cover the cost of the RCE (\$770.00) for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

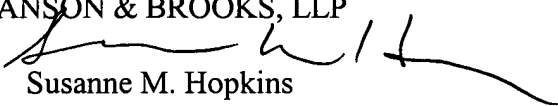
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310.00 DP

Respectfully submitted,

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PATENT TRADEMARK OFFICE